



Atty. Dkt. No. 054270/0122

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Michael Herman Koch et al.  
Title: FABRICATION OF ZINC OXIDE FILMS  
ON NON-PLANAR SUBSTRATES AND  
THE USE THEREOF  
Appl. No.: 09/403,505  
Filing Date: February 1, 2000  
Examiner: Brian K. Talbot  
Art Unit: 1762

#12/13/00  
12/13/00  
(A2)

**AMENDMENT**

Commissioner for Patents  
Box NON-FEE AMENDMENT  
Washington, D.C. 20231

Sir:

In reply to the Office Action dated July 28, 2000, the period for reply extending to November 28, 2000 by virtue of a petition and fee for a one-month extension of time, please amend the application as follows:

**In the Claims:**

Please amend the claims as follows:

1. (Amended) A method of [manufacture of] manufacturing a substantially continuous circumferential coating on a [non-planer] non-planar substrate, said method comprising: [the step of:]  
utilizing a substantially non directional gaseous deposition technique and a substantially static substrate deposition geometry to deposit said coating on said non-planar substrate.

Claim 2, line 2, change "characteritics" to --characteristics--.

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